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SCREEN Completes the Construction of New Factory S³-5 for Semiconductor Production Equipment

Kyoto, Japan – January 17, 2024 – SCREEN Holdings Co., Ltd. has finalized construction of S³-5 (S-Cube 5), its new factory specifically designed for semiconductor production equipment. Work on the facility had been continuing at our existing Hikone Site since February 2023.



S³-5 (S-Cube 5)

Please download the photo from:
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Overview of New Factory

Name:	S ³ -5 (S-Cube 5) (S ³ stands for Safety, Smart, and Speed)
Location:	480-1 Takamiya-cho, Hikone, Shiga, Japan
Building area:	Approx. 4,500 m ²
Total floor area:	Approx. 13,534 m ²
Construction type:	Three story, steel frame building
Total cost:	Approx. 8 billion yen
Operation starts:	January, 2024
Main business:	Production of single wafer cleaning equipment, and other

SCREEN Holdings is also continuing to move forward with initiatives to reduce the environmental impact of its production facilities. As a result, all clean rooms to be set up during its latest expansion will be equipped with energy-saving air conditioning systems.

Related news release (Announced on July 27, 2022)

SCREEN Strengthens Its Production and Service Systems for Semiconductor Production Equipment: Major Capital Investment Plan Targets Hikone Plant plus Three Domestic Group Companies

URL: www.screen.co.jp/en/news/NR220727E